

PATENT
Atty Docket No. KLAC0003 Layes

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

DIETER MUELLER ET AL.

Title: COPPER CMP FLATNESS

MONITOR USING GRAZING INCIDENCE

INTERFEROMETRY

Serial No.: 09/693,614

Filed: October 20, 2000

Group Art Unit: 2877

Examiner: Hwa S. Lee

RESPONSE TO OFFICE ACTION

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated April 23, 2003, please enter the following amendments and consider the following remarks in connection with the above-identified patent application.